Special Issue

Thin Film Technologies in Sensors Fabrication

Message from the Guest Editor

The goal of this Special Issue on *Thin Film Technologies in Sensor Fabrication* is to give a survey of the state-ofthe-art on organic and inorganic thin-film-based sensors and introduce recent progress achieved in the fabrication and application of these devices. All who conduct research in this area and have results that contribute to the further development of thin-film-based sensors are invited to participate in our project. You can contribute both original research papers and reviews to this Special Issue.

- chemical sensors; physical sensors; optical sensors; biosensors
- gas sensors; flexible sensors; humidity sensors; temperature sensors; pressure sensors; thin-film sensor arrays
- design; fabrication; microfabrication; testing; detection principles; optimization
- sensing materials; metal oxides; polymers; carbon; electrodes
- deposition technologies

Guest Editor

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Deadline for manuscript submissions

closed (31 March 2021)



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Message from the Editor-in-Chief

Sensors is a leading journal devoted to fast publication of the latest achievements of technological

developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

Editor-in-Chief

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